



DFW  
✓

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Miwa KOZAWA et al.**

Group Art Unit: **1752**

Serial Number: **10/629,806**

Examiner: **Sin J. Lee**

Filed: **July 30, 2003**

Confirmation No.: **9494**

For: **RESIST PATTERN THICKENING MATERIAL, PROCESS FOR  
FORMING RESIST PATTERN, AND PROCESS FOR  
MANUFACTURING SEMICONDUCTOR DEVICE**

Attorney Docket Number: **030923**

Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

September 29, 2005

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 29, 2005 for 2 months from July 29, 2005 to September 29, 2005.

Attached please find a check in the amount of **\$450.00** to cover the cost of the extension.

If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

09/30/2005 SSITHIB1 00000039 10629806

01 FC:1252

450.00 OP

Shuji Yoshizaki

Limited Recognition

Telephone: (202) 822-1100

Facsimile: (202) 822-1111

SY/mt

Q:\2003\030923\030923 EOT amd-3.doc